

REMARKS

Claims 1 and 3-18 are pending in the application. Claims 1, 7 and 13 have been amended by way of the present amendment. Reconsideration is respectfully requested.

In the outstanding Office Action, claims 1, 3-6, 13-16 and 18 are rejected under 35 U.S.C. 103(a) as being unpatentable over the Applicants prior art figure 2B (APAF) in view of U.S. Patent Publication 20020122280 (Ker et al) and U.S. Patent 6,194,776 (Amano); claims 7, 8, 10-12, and 17 are rejected under 35 U.S.C. 103 (a) as being unpatentable over the APAF in view of Ker et al. Reconsideration is respectfully requested.

35 U.S.C. 103 Rejections

In the outstanding Office Action, claims 1, 3-6, 13-16 and 18 are rejected under 35 U.S.C. 103(a) as being unpatentable over the Admitted Prior Art (APA) in view of Ker et al, and Amano. Moreover, claims 7, 8, 10-12 and 17 are rejected under 35 U.S.C. 103 (a) as being unpatentable over the APAF in view of Ker et al. Applicants respectfully disagree with these conclusions and traverse this rejection as follows.

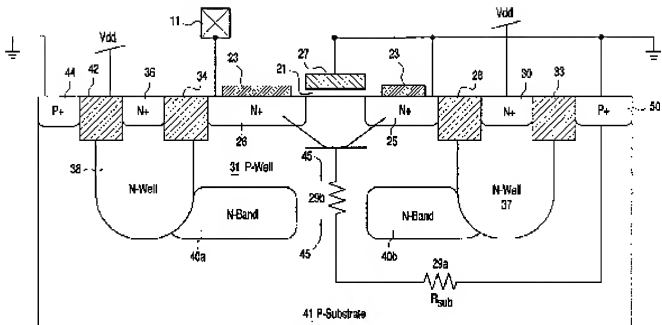
Claims 1, 7 and 13 have been amended to clarify the invention. In particular, claim 1 has been amended to recite:

a path of ~~said substrate material~~ extending through a single opening in said segmented conductive band ~~configured to increase having a distance and doping level that increases~~ substrate resistance by creating a single extended path for current which flows through said I/O pad to substrate contacts and drain during an ESD event and electrically connecting the first well to the substrate.

Claims 7 and 13 have been similarly amended. Support for the claim amendments can be found in paragraphs [0026] through [0028] of the specification. That is, as shown in **FIG. 4** and the specification discloses a triple well ESD NMOSFET transistor has drain **26** and source **25** diffusion regions formed within a P-well **31**. Further, **FIG. 4** and the specification disclose an

opening 45 is provided between N-band segments 40a and 40b through which P-well 31 is electrically connected to the substrate 41 and the result is a resistive path from P-well 31, represented as 29a and 29b, to a substrate contact 44 and 50 located outside of the N-wells. In particular, the specification discloses the effect of this structure is to provide an increased resistive path from the P-well 31 to substrate contacts 44 and 50 and that *the distance between substrate contact 44 and 50 and P-well region 31 through the gap in N-band region 40 and the lighter doping of the substrate 41 increases the substrate resistance* (emphasis added).¹

FIG. 4



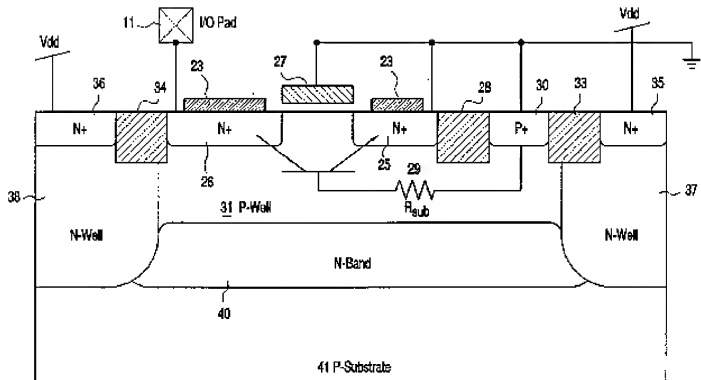
Therefore, it is respectfully submitted that the amendment raises no questions of new matter.

The APA referred to in the outstanding Office Action discloses a conventional implementation of an ESD NMOSFET as shown in FIG. 2 below. Ker et al. discloses an ESD protection component with a deep-N-well structure. The ESD protection component comprises a lateral silicon controlled rectifier (SCR) and a deep N-well. The SCR comprises a P-type layer, an N-type layer, a first N-well and a first P-well. The P-type layer is used as an anode of the SCR; the N-type layer is used as a cathode of the SCR; the first N-well is located between the P-

¹ U.S. Patent Application Publication No. US 2005/0224882 at **FIG. 4** and paragraph [0028].

type layer and the N-type layer and is contacted with the P-type layer; and the first P-well is contacted to the first N-well and the N-type layer. The deep N-well is located between the first P-well and the P-substrate, and is used to isolate the electric connection between the P-substrate and the first P-well. A plurality of these ESD protection components arbitrarily connected in series increases the total holding voltage of ESD protection circuit, thus preventing occurrences of latch-up.²

FIG.2B



Amano discloses a semiconductor circuit device having a triple-well structure wherein a predetermined potential level is supplied to a top well without a contact region formed in the top well is disclosed. In an N-type ion implantation step for forming an N-type well region (1) in a P-type semiconductor substrate (5), a mask of a predetermined configuration is used so that ions are not implanted into a region of a portion which is to serve as a bottom portion (1B) of the well

² See Ker et al., at Abstract.
 666617_1.DOC

region (1). Then, the N-type well region (1) is formed which is shaped such that a portion (6) having P-type properties remains partially in the bottom portion (1B). The P-type portion (6) establishes electrical connection between a P-type well region (2) and the semiconductor substrate (5) to permit the potential applied to a contact region (4) to be supplied to the well region (2) therethrough. The portion (6) may include a plurality of portions (6) which allow uniform potential supply. This structure may be applied to basic cells of a memory cell array block.³

Ker et al. fails to disclose, as amended claim 1 has been amended to recite:

a path of said substrate material extending through a single opening in said segmented conductive band ~~configured to increase~~ having a distance and doping level that increases substrate resistance by creating a single extended path for current which flows through said I/O pad to substrate contacts and drain during an ESD event and electrically connecting the first well to the substrate.

Claims 7 and 13 have been similarly amended. That is, in the present invention, the distance of the path and the doping increases substrate resistance. In this regard, the single opening recited in claim 1 plays an the role of limiting the current flow to the single extended path. That is, by providing a single opening, of a “distance and doping level” through which current flows, a single, extended, current pathway through the opening is established yielding consistent and potentially larger substrate resistance then would be provided by a similar structure with *a plurality of openings that provide multiple current pathways.*

In contrast to the claimed invention, Ker et al., as indicated in the outstanding Office Action, discloses a plurality of openings is provided in the conductive band region. Intuitively, such a plurality of openings would serve to reduce the substrate resistance (i.e., due to the multiple current pathways which is similar to resistances in parallel which are always lower in resistance than one in series) and *not* increase the resistance by providing a range of current pathways of differing lengths. The different pathway lengths would correspond to different

³ See Amano at Abstract.

substrate resistance values with an overall substrate resistance value tending to a lower value (i.e., the above-discussed parallel resistance concept) rather than the increased substrate resistance generated by the path “having a distance and doping level,” as recited in amended claim 1 of the present invention. Moreover, neither Amano nor the APA can make up for this deficiency in Ker et al.

Claim 13 reciting language similar to that in amended claim 1 recites in pertinent part:

a resistive path *having a distance and doping level that increases substrate resistance and extends* through a single opening in said segmented conductive band region to said substrate contacts, said resistive path minimizing the trigger voltage for said FET (emphasis added).

That is, in the present invention, a current pathway “having a distance and doping level that increases substrate resistance and extends through a single opening” lends itself to increasing substrate resistance and minimizing the trigger voltage of an FET in accordance with the present invention. Applicant respectfully submits, therefore, that none of the APAF, Ker et al. and Amano whether taken alone or in combination, disclose the present invention and that claims 1 and 13 patentably distinguish thereover. Applicant, therefore, respectfully requests that the rejections of claims 1 and 13 under 35 U.S.C. 103 (a) be withdrawn. Moreover, claims 3-6, and 14-16 and 18 are respectively dependent on independent claims 1 and 13. Accordingly claims 3-6, 14-16 and 18 are patentable for at least the same reasons that independent claims 1 and 13 are patentable.

With respect to the rejection of claims 7, 8, 9, 10-12, and 17, Applicant responds as follows.

Amended claim 7 recites in pertinent part:

providing a resistive path having a distance and doping level that increases substrate resistance and extends through a single opening in a segmented conductive band from said well to substrate contacts located outside of said wells, whereby the trigger voltage of the said ESD NMOSFET is minimized due to the length

of said resistive path between said substrate contacts and said I/O pad (emphasis added).

As discussed above in conjunction with the rejections of claim 1 and 13, the length of the resistive path in the present invention minimizes the trigger voltage of a device in accordance with the present invention. Applicant therefore respectfully submits that neither the APAF nor Ker et al., whether taken alone or in combination, discloses the present invention and that claim 7 patentably distinguishes thereover. Applicant, therefore, respectfully requests that the rejections of claim 7 under 35 U.S.C. 103 (a) be withdrawn. Moreover, claims 8, 9, 10-12 and 17 are dependent on independent claim 7. Accordingly, claims 8, 9, 10-12 and 17 are patentable for at least the same reasons that independent claim 7 is patentable.

CONCLUSION

Applicant believes no fee is due with this response. However, the Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our

Deposit Account No. 22-0185, under Order No. 21806-00158-US.

Dated: February 26, 2009

Respectfully submitted,

Electronic signature: /Myron Keith Wyche/
Myron Keith Wyche
Registration No.: 47,341
Edmund Christian
Of Counsel
CONNOLLY BOVE LODGE & HUTZ LLP
1875 Eye Street, NW
Suite 1100
Washington, DC 20006
(202) 331-7111
(202) 293-6229 (Fax)
Agent for Applicant